

# Tao-Ming Chen

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/9740763/publications.pdf>

Version: 2024-02-01

2  
papers

29  
citations

2682572

2  
h-index

2917675

2  
g-index

2  
all docs

2  
docs citations

2  
times ranked

6  
citing authors

#	ARTICLE	IF	CITATIONS
1	Applying Data Augmentation and Mask R-CNN-Based Instance Segmentation Method for Mixed-Type Wafer Maps Defect Patterns Classification. IEEE Transactions on Semiconductor Manufacturing, 2021, 34, 455-463.	1.7	23
2	Integrating content-based image retrieval and deep learning to improve wafer bin map defect patterns classification. Journal of Industrial and Production Engineering, 2022, 39, 614-628.	3.1	6